

Notice of References Cited	Application/Control No. 10/815,905	Applicant(s)/Patent Under Reexamination LIN ET AL.	
	Examiner HOANG TRAN	Art Unit 2874	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,835,255	11-1998	Miles, Mark W.	359/291
	B	US-			
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	D	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Matsumoto, "Novel prevent method of stiction using silicon anodization for SOI", 9/4/1998, Elsevier Science, Volume A72, pg153-159.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.